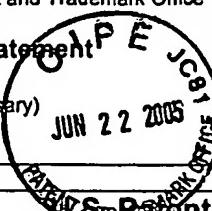
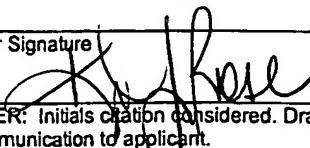


Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-024004	Application No. 10/713,275
Information Disclosure Statement by Applicant <small>(Use several sheets if necessary)</small> <small>(37 CFR §1.98(b))</small>		 Applicant Isamu Kobori, et al.		
		Filing Date November 17, 2003	Group Art Unit 2822	

Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
KR	AA	5,183,780	02/02/1993	Noguchi et al.			02/20/1991
	AB	5,341,012	08/23/1994	Misawa et al.			07/31/1992
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	AK						

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes No
	AL						
	AM						
	AN						
	AO						
	AP						

Other Documents (include Author, Title, Date, and Place of Publication)							
Examiner Initial	Desig. ID	Document					
	AQ						
	AR						
	AS						
	AT						

Examiner Signature 	Date Considered 9/15/05
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-024004	Application No.
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Isamu Kobori et al.	
		Filing Date	Group Art Unit

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	AV							

Other Documents (include Author, Title, Date, and Place of Publication)	
Examiner Signature 	Date Considered 2/8/05 9/15/05
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Isamu Kobori et al.	
		Filing Date	Group Art Unit

Examiner Initial	Desig. ID	Document	
Kf	AW	Y. Fukushima, et al., "A Poly-Si TFT Process for High Speed and Low Voltage CMOS Circuits", Extended Abstracts of the 1993 International Conference on Solid State Devices and Materials, Makuhari, pp. 993-995, 1993.	
	AX		

Examiner Signature 	Date Considered 2/8/05 9/15/05
EXAMINER Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	